

UNITED STATES

DECLARATION FOR PATENT APPLICATION Docket No. NECW 18.281

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name.

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled METHOD OF VAPOR PHASE GROWTH OF METAL OXIDE DIELECTRIC FILM AND APPARATUS FOR VAPOR PHASE GROWTH OF METAL OXIDE DIELECTRIC MATERIAL the specification of which

(check one) ☒ is attached hereto.

☐ was filed on _____ as

Application Serial No. _____

and was amended on _____ (if applicable).

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by an amendment referred to above.

I acknowledge the duty to disclose information which is material to the examination of this application in accordance with Title 37, Code of Federal Regulations, §1.56(a).

I hereby claim foreign priority benefits under Title 35, United States Code, §119 of any foreign application(s) for patent or inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:

Prior Foreign Application(s)			Priority Claimed
<u>219183/1998</u>	<u>Japan</u>	<u>03/08/1998</u>	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No
(Number)	(Country)	(Day/Month/Year Filed)	
<u>219184/1998</u>	<u>Japan</u>	<u>03/08/1998</u>	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No
(Number)	(Country)	(Day/Month/Year Filed)	
<u>219187/1998</u>	<u>Japan</u>	<u>03/08/1998</u>	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No
(Number)	(Country)	(Day/Month/Year Filed)	

I hereby claim the benefit under Title 35, United States Code, §120 of any United States application(s) listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of Title 35, United States Code, §112, I acknowledge the duty to disclose material information as defined in Title 37, Code of Federal Regulations, §1.56(a) which occurred between the filing date of the prior application and the national or PCT international filing date of this application:

(Application Serial No.)	(Filing Date)	(Status - patented, pending, abandoned)
(Application Serial No.)	(Filing Date)	(Status - patented, pending, abandoned)

☒ I hereby appoint as my attorney and agent Aaron B. Karas, Reg. No. 18,923, Samson Helfgott, Reg. No. 23,072 and Emma Shleifer, Reg. No. 29,734 to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith:

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I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

Full name of sole or first inventor Toru TATSUMI

Inventor's signature Toru Tatumi Date January 19, 2001

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Full name of second joint inventor, if any Atsushi YAMASHITA

Second Inventor's signature Atsushi Yamashita Date January 19, 2001

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Filed Via Express Mail
Rec. No.: **EL522399606US**
On: **January 29, 2001**

On: **January 29, 2001**

A hand-drawn diagram of a cell. It features a large, irregular outer boundary representing the cell membrane. Inside this boundary is a smaller, roughly circular structure representing the nucleus. The space between the nucleus and the outer boundary is filled with small, scattered dots, representing the cytoplasm.

By L. S. S.

Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 08-1634.

Attorney Docket No.: NECW 18.281

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors : Toru TATSUMI, *et al.*

Filed : Concurrently Herewith

Title : METHOD OF VAPOR PHASE GROWTH OF METAL
OXIDE DIELECTRIC FILM AND APPARATUS FOR
VAPOR PHASE GROWTH OF METAL OXIDE
DIELECTRIC MATERIAL

January 29, 2001


Assistant Commissioner for Patents
Box PCT
Washington, D.C. 20231

SUB-POWER OF ATTORNEY

S I R:

I, Aaron B. Karas, 18,923 attorney of record herein, do hereby grant a sub-power of attorney to Leonard Cooper, Reg. No. 27,625; Harris A. Wolin, Reg. No. 39,432; Linda S. Chan, Reg. No. 42,400; Brian Myers Reg. No. 46,947; Michael Markowitz, Reg. No. 30,659 to act and sign in my behalf in the above-referenced application.

Respectfully submitted


Aaron B. Karas; Reg. No. 18,923

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